

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Mitsuru Ozono et al.
Serial No.: N/A
Filing Date: Herewith
Title: "METHOD AND APPARATUS FOR PICKING UP SEMICONDUCTOR CHIP AND SUCTION AND EXFOLIATION TOOL USED THEREFOR
Docket No.: 35857

INFORMATION DISCLOSURE STATEMENT

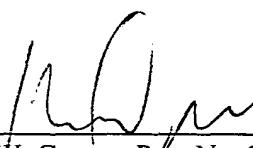
Mail Stop PATENT APPLICATION
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In accordance with Rule 56, applicants are aware of the publications listed in the enclosed copy of Patent Office Form 1449. A copy of each of the publications is enclosed herewith.

Respectfully submitted,
PEARNE & GORDON LLP

By: _____


Michael W. Garvey, Reg. No. 35878

526 Superior Avenue East
Suite 1200
Cleveland, Ohio 44114-1484
(216) 579-1700

July 15, 2003

Express Mail Label No. EV341098585US

INFORMATION DISCLOSURE CITATION
BY APPLICANT
(USE SEVERAL SHEETS IF NECESSARY)APPLICANT:
Mitsuru Ozono et al.FILING DATE:
Herewith

GROUP ART UNIT:

U.S. PATENT DOCUMENTS

Examiner Initial		Document No.	Date	Name	Class	Subclass	Filing Date If Appropriate
	A						
	B						
	C						
	D						
	E						
	F						
	G						
	H						
	I						
	J						

FOREIGN PATENT DOCUMENTS

		Document No.	Date	Country	Class	Subclass	Translation
	K	05-335405	12/1993	Japan			English abstract
	L	06-061347	3/1994	Japan			English abstract
	M	11-274181	10/1999	Japan			English abstract
	N	2001-118862	4/2001	Japan			cited on pg 2 of spec.
	O						

OTHER REFERENCES (Including Author, Title, Date, Page numbers, Etc.)

	P	
--	---	--

Examiner: _____ Date Considered: _____

*Examiner: Initial if reference considered, regardless of whether citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.